



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1853**  
Shoriki NARITA et al. : Docket No. 2001-1876A  
Serial No. 10/019,700 : Group Art Unit 2825  
Filed January 2, 2002 : Examiner Igwe U. Anya

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FEB 17 2004

BUMP FORMING APPARATUS FOR :  
CHARGE APPEARANCE SEMICONDUCTOR  
SUBSTRATE, CHARGE REMOVAL METHOD  
FOR CHARGE APPEARANCE SEMICONDUCTOR  
SUBSTRATE, CHARGE REMOVING UNIT FOR  
CHARGE APPEARANCE SEMICONDUCTOR  
SUBSTRATE, AND CHARGE APPEARANCE  
SEMICONDUCTOR SUBSTRATE

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

*Responsive to the Office Action of October 2, 2004, a two month extension of time being filed concurrently herewith, please amend the above-identified application as follows.*